MAIL STOP AMENDMENT

HE UNITED STATES PATENT AND TRADEMARK OFFICE

N.B. Cobb

Attorney Docket No.: MEGC121783

Application No.: 10/696,276

Art Unit: 2123 / Confirmation No.: 6511

Filed:

October 29, 2003

Examiner: J.C. Ochoa

Title:

METHOD AND APPARATUS FOR PERFORMING OPC USING MODEL

CURVATURE -

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Seattle, Washington 98101

February 8, 2007

TO THE COMMISSIONER FOR PATENTS:

Applicant is aware of the information listed in the attached form that may be material to the prosecution of the above-identified patent application.

1.	<u>X</u>	Copies of documents previously submitted as documents Cite No. O3 and O12 are resubmitted and enclosed for the Examiner's convenience.			
2.	<u>X</u>	Pursuant to 37 C.F.R. § 1.97(c), this Information Disclosure Statement is being filed after the period set forth in 37 C.F.R. § 1.97(b) but before the mailing date of a final action under 37 C.F.R. § 1.113, a Notice of Allowance under 37 C.F.R. § 1.311, or an action that otherwise closes prosecution, and is accompanied by:			
	a.	a certification statement as specified in 37 C.F.R. § 1.97(e); or			
	b.	x the submission fee set forth in 37 C.F.R. § 1.17(p). Check No. 174024 in the amount of \$180 is enclosed.			

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The Commissioner is hereby authorized to charge any fees which may be required 3. \mathbf{X}_{-} or credit any overpayment to Deposit Account No. 03-1740. A copy of this document is enclosed.

Respectfully submitted,

CHRISTENSEN O'CONNOR JOHNSON KINDNESSPLLC

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I hereby certify that this correspondence is being deposited with the U.S. Postal Service in a sealed envelope as first-class mail with postage thereon fully prepaid and addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the below date.

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RCT:pt

<u>EMENTAL INFORMATION CITED BY APPLICANT THAT MAY BE MATERIAL</u> TO THE PROSECUTION OF THE SUBJECT APPLICATION

Applicant:

N.B. Cobb

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Group Art Unit: 2123/Confirmation No. 6511

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U.S. PATENT DOCUMENTS

None

FOREIGN PATENT DOCUMENTS

None

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

*Examiner	Cite	
Initial	No.	
	О3	Previously submitted on 2/5/04 and enclosed for Examiner's convenience:
		Cobb, N., et al., "Mathematical and CAD Framework for Proximity Correction," <i>Proceedings of the International Society for Optical Engineering</i> 2726: 208-222, 1996.
	O12	Previously submitted on 2/5/04 and enclosed for Examiner's convenience:
		Vacca, A., et al., "Techniques to detect and analyze photomask CD uniformity errors," <i>Proceedings of SPIE</i> , 19th Annual Symposium on Photomask Technology, Paper 3873-21, Pages 209-214, 1999.
Examiner		Date Considered

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. RCT:pt

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